

<b>U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE</b>			
<b>REQUEST FOR REFUND</b>		Docket Number: <b>11403/84</b>	
Application Number: <b>10/713,172</b>	Filing Date: <b>November 14,2003</b>	Examiner: <b>Francis P. Smith</b>	Art Unit: <b>4151</b>
Title: <b>CRACK AND RESIDUE FREE CONFORMAL DEPOSITED SILICON OXIDE WITH PREDICTABLE AND UNIFORM ETCHING CHARACTERISTICS</b>		Inventors: <b>Aaron Partridge et al.</b>	

Commissioner for Patents  
P.O. Box 1450  
Alexandra, VA 22313-1450

Sir:

On April 17, 2008 the Applicants electronically filed an Amendment for the above-captioned application. The attorney of record authorized the Commissioner to charge all fees to the Deposit Account of Kenyon & Kenyon LLP, deposit account number **11-0600**.

It is our understanding that the Commissioner charged the Deposit Account of the previous attorney of record, Deposit Account Number 50-0763. Accordingly, Applicants respectfully request that the extra claim fees of \$470.00 be credited back to the Deposit Account No. 50-0763 and that the extra claim fees of \$470.00 be charged to the deposit account of Kenyon & Kenyon LLP, deposit account number **11-0600**.

While no fees are believed to be due in connection with this Communication, the Commissioner is authorized, as appropriate and/or necessary, to charge any fees or credit any overpayment to Deposit Account No. **11-0600**.

Respectfully submitted,

Date: June 17, 2008

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